

IN THE ABSTRACT OF THE DISCLOSURE

Please replace the Abstract of The Disclosure with the following new Abstract of the Disclosure:

The present invention relates to a method for manufacturing a light-emitting device. At least one of a light-emitting film forming step, a conductive film forming step and an insulating film forming step is carried out while holding a substrate in a manner that an angle subtended by a surface of the substrate and the direction of gravity is within a range of from 0 to 30°.